

## Electronic Patent Application Fee Transmittal

Application Number:	10590783			
Filing Date:	25-Jun-2007			
Title of Invention:	Illumination System For A Microlithography Projection Exposure Installation			
First Named Inventor/Applicant Name:	Damian Fiolka			
Filer:	Howard Leonard Bernstein/Lizbeth Chow			
Attorney Docket Number:	Q96197			

Filed as Large Entity

### **U.S. National Stage under 35 USC 371 Filing Fees**

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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**Basic Filing:**

**Pages:**

**Claims:**

**Miscellaneous-Filing:**

**Petition:**

**Patent-Appeals-and-Interference:**

**Post-Allowance-and-Post-Issuance:**

**Extension-of-Time:**

Extension - 2 months with \$0 paid	1252	1	490	490
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>490</b>